

Docket No. NEC04P012-TOb
WAK.163



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Takashi OGURA, et al.

Serial No.: 10/561,608

Group Art Unit: 2814

Filing Date: December 20, 2005

Examiner: Hoai V. Pham

For: SEMICONDUCTOR DEVICE AND PRODUCTION METHOD THEREFOR

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated April 20, 2007, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

Amendments to the claims begin on page 2 of this paper. The amendments to the claims do not add new matter.

Remarks begin on page 6 of this paper.